

Actuator arrangement for active vibration isolation using a payload as an inertial reference mass

The invention relates to an actuator arrangement for active vibration isolation, comprising an inertial reference mass.

5 Figure 1 shows an active vibration isolation system according to the prior art. The system comprises a payload 2 which, e.g., may be a metroframe in a lithography machine. A velocity sensor 4 is attached to the payload 2. Instead of a velocity sensor, an acceleration sensor may be used. The sensor 4 may be a geophone.

 The sensor 4 is connected to a controller 6, sometimes referred to as "sky
10 hook" controller. The controller 6 may be any suitable programmed (micro)computer.

 However, analog and digital circuits may be used where appropriate.

 An actuator 8 is provided between the payload 2 and "ground" 16. The controller 6 is connected to the actuator 8 to provide the actuator 8 with a suitable input signal. In practice, an amplifier (not shown) is located between the controller 6 and the
15 actuator 8 to generate a power signal to be sent to actuator 8 based on the controller output signal. It is observed that the connections between the sensor 4, the controller 6 and the actuator 8 are shown as physical lines. However, as known to a person skilled in the art, these connections may be wireless connections. This observation also holds for other connections shown in embodiments of the present invention.

20 The actuator 8 is shown in a schematic way. The actuator 8 may be a Lorentz motor or any other suitable actuator arranged to generate forces as controlled by controller 6.

 Figure 1 also shows an airmount 10 comprising a piston 12 and a housing 14 in which the piston 12 can move up and down. In use, the housing 14 is filled with air (or any other suitable gas). A valve 20 is provided that is connected to the housing 14 by means of a
25 channel 21. A controller is connected to the valve 20 to control its operation. A sensor 18 is provided to measure the distance z_1 between the housing 14 of the airmount 10 and the payload 2. The sensor 18 is connected to a comparator 17, which also receives a reference signal z_{1ref} . The sensor 18 generates an output signal indicative of the distance z_1 . The

comparator 17 generates an output signal that is proportional to the difference between z_{1ref} and the output of sensor 18 and applies this to the controller 19. The controller 19 actuates the valve 20 in such a way that the distance z_1 is controlled at the desired level z_{1ref} .

The controllers 6 and 19 need not be separate physical units. They may be
5 implemented as separate programs running on the same computer.

In practice, the payload 2 may be very heavy, e.g. 3000 kilograms or more. It is not strictly necessary that the airmount 10 is provided as an actively controlled arrangement. It may, alternatively, be a passive vibration isolation arrangement. Instead of an airmount 10, other vibration isolation arrangements such as a spring, may be used.

10 In practical situations, as will be evident to a person skilled in the art, there will mostly be three or four airmounts 10 to support the payload 2. Moreover, Figure 1 shows one actuator arrangement, including the sensor 4, the controller 6 and the actuator 8; however, in practice there may be multiple actuator arrangements. The actuator arrangements are then arranged to provide vibration isolation in any of six degrees of freedom (x , y , z and
15 rotations about x , y and z), or combinations of the different degrees of freedom.

The sensor 4 may be a geophone that, as known to persons skilled in the art, comprises a reference mass, or inertial mass, against which displacement of mass 2 is measured.

Figure 2 shows another example of a prior art active vibration isolation
20 system, as disclosed by P.G. Nelson, *An active vibration isolation system for inertial reference and precision measurement*, Rev. Sci. Instr. 62(9), September 1991, pp. 2069-2075. Figure 2 shows a ceiling 23 that can be conceived to be "earth". The ceiling 23 is at height z_c . A mass 27 is suspended from the ceiling 23 by a spring 35. An actuator 25 is located between the ceiling 23 and the mass 27 to control a height z_2 at which mass 27 is
25 located.

A mass 29 suspends from the mass 27 by a spring 37. The mass 29 is at a height z_3 . A sensor 33 senses a distance d between masses 27 and 29. The sensor may be a capacitive sensor. The distance d is a measure of the difference between heights z_2 and z_3 : $z_2 - z_3$. The sensor 33 generates a feedback signal to a controller 31 that, based upon this
30 feedback signal, generates a control signal for the actuator 25.

In the prior art the system as shown in Figure 2 is used follows: sensor 33, spring 37, and mass 29 together form a seismometer where mass 29 is a reference mass, or inertial mass of the seismometer. It is shown that by feeding back the distance signal d to the controller 31, the transmissibility of z_2/z_c is improved. So this document discloses that

dependency of movement of a mass suspended from "earth" on the movement of the earth can be reduced by feeding back a distance signal relating to a distance between this mass and another, inertial reference mass.

5 In none of the prior art documents, the inertial mass has another purpose than being a reference mass against which displacement of a mass to be controlled is measured. The object of the present invention is to provide an active vibration isolation system that improves the vibration isolation of a payload in view of both prior art documents.

10 To achieve this object, the present invention provides an active vibration isolation system arranged to isolate a payload from earth movements, the payload being supported by means of at least one spring, the system comprising a sensor for sensing a displacement of the payload and generating a displacement signal, a controller for receiving the displacement signal and generating a control signal based on the displacement signal, and
15 an actuator arranged to generate an actuation force based on the control signal, characterized in that the system comprises a mass supporting the payload, the sensor is arranged to sense a displacement of the payload relative to the mass, and the actuator is arranged to apply the actuating force to the mass, such that the payload is used as an inertial reference mass.

Thus, the invention is based on the insight that the payload whose vibrations
20 need to be controlled can be used as a reference mass, or inertial mass, on which all kinds of different industrial processes can be performed. It can be shown that by the arrangement according to the invention, the payload is better isolated from earth movements than in both prior art arrangements as shown in Figures 1 and 2. Especially at lower frequencies, displacement measurements outperform velocity measurements and provide better active
25 isolation. Moreover, no actuator is needed to control movements of the payload directly.

The invention also relates to a lithography apparatus provided with an active vibration isolation system as defined above. However, the invention can equally well be applied in any other high-precision machine.

The invention also relates to a method of active vibration isolation to isolate a
30 payload from earth movements, comprising:

- supporting the payload by means of at least one spring,
- providing a sensor for sensing a displacement of the payload and generating a displacement signal,
- generating a control signal based on the displacement signal,

- generating an actuation force based on the control signal,
characterized by
- supporting the payload by a mass,
- sensing a displacement of the payload relative to the mass,
- 5 - applying the actuating force on the mass, such that the payload is used as an
inertial reference mass.

Below, the invention will be illustrated in detail with reference to some
10 drawings. These drawings are only intended to clarify the present invention and show some
embodiments only. They are not intended to limit the invention in any way. The present
invention is only limited by the annexed claims and its technical equivalents.

Fig. 1 shows an active vibration isolation system according to the prior art;
Fig. 2 shows another active vibration isolation system according to the prior
15 art;

Fig. 3 shows an active vibration isolation system according to the invention;
Fig. 4 shows an example of a transmissibility of the system according to
Figure 3;

Fig. 5 shows an alternative embodiment of the invention.
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Figures 1 and 2 have been explained above.

Figure 3 shows a first mass 51 supported by the earth 16 by supporting
devices, like legs. Since these supporting devices will have a limited stiffness, they are shown
25 as springs 53, 55. Although two supporting devices 53, 55 are shown, in practice there may
be three or maybe more supporting devices. A second mass 41 is supported by the first mass
51 by means of a spring 45. Again, in practice there may or will be more springs between the
first and the second mass. A third mass 39 is supported by the second mass 41 by means of a
spring 43. Again, there may be more than one spring between the third mass 39 and the
30 second mass 41. The third mass 39 is a payload. In use, the payload 39 supports one or more
devices 57 used in one or more industrial processes. The first mass 51 need not be present.
Then, second mass 41 is supported directly by earth 16.

This setup of three different masses 39, 41, 51, can e.g. be used in lithographic
equipment. In a lithographic apparatus, the first mass 51 may be a base frame with a mass of

2000 kg, the second mass 41 may be a sub-frame with a mass of 4000 kg, whereas the third mass 39 may be a metroframe with a mass of 3200 kg. In such a lithographic apparatus, the springs 43, 45 will have different spring constants. E.g., the spring 43 may be selected such that it provides the third mass 39 with an eigenfrequency in the range from 0.1-10 Hz, e.g.,
5 0.3 Hz. The spring 45 may be arranged such that it provides the second mass 41 with an eigenfrequency in the range from 1-10 Hz, e.g., 3 Hz. The supporting devices 53, 55 may be such that they provide the first mass 51 with an eigenfrequency in the range from 30-40 Hz, e.g., 35 Hz, or higher.

In a lithographic apparatus, the metroframe 39 supports devices 57 that may
10 include accelerometers, projection lenses and one or more sensors.

The first mass 51 is shown to have a displacement z_7 , the second mass 41 is shown to have a displacement z_6 , whereas the third mass 39 is shown to have a displacement z_5 . Earth 16 is shown to have a displacement h . A sensor 59 is provided to measure a change of a distance d_2 , i.e., a displacement between the second mass 41 and the third mass 39. This
15 change of distance d_2 is a measure of the difference between z_5 and z_6 : that is $z_5 - z_6$. The sensor 59 generates an output signal that is an indication of the change of distance d_2 . This output signal is transmitted to a controller 49. The controller 49 generates a control signal based on this output signal of sensor 59. The control signal is transmitted to an actuator 47. The actuator 47 actuates the second mass 41. This actuator 47 may be a Lorenz motor or any
20 other suitable actuator arranged to generate forces F as actuated by controller 49. In the arrangement as shown in Figure 3, the payload 39 itself functions as an inertial reference mass.

Using the change of distance d_2 as an input to the controller 49 turns out to provide a very good active isolation of the payload 39 supporting devices 57. This is shown
25 in Figure 4. Figure 4 shows the transmissibility of z_5/h , both in a passive mode and an active mode. In the passive mode, the controller 49 is turned off, whereas in the active mode the controller 49 is turned on. Figure 4 shows that, in the active mode, the transmissibility z_5/h is much better. That is, the dependency of movements of the payload 39 on the earth 16 is reduced. This reduction already starts with very low frequencies in the design of Figure 3
30 when the springs 43, 45 have eigenfrequencies as indicated above. These eigenfrequencies of 0.3 Hz for spring 43, 3 Hz for spring 45, and 35 Hz for supporting devices 53, 55 can be recognized in the passive mode transmissibility z_5/h in Figure 4.

As indicated above, for the application of the present invention it is not strictly necessary that there is a first mass 51 which is supported by the earth 16 by means of

supporting devices 53, 55. Instead, the second mass 41 can be directly supported by the earth 16 by means of the spring 45 and as controlled by actuator 47.

The springs 43, 45 can be any suitable spring as desired. They may be passive springs. They may also be airmounts as shown in the prior art according to Figure 1.

5 Figure 5 shows an alternative embodiment of the present invention. Like reference signs refer to like components of earlier Figures. Differences from the embodiment according to Figure 3 are as follows. The arrangement comprises a first filter 61 between the sensor 59 and the controller 49. Moreover, a further sensor 58 is provided to sense the distance d_3 between payload 39 and either first mass 51 or earth 16. The sensor 58 is
10 connected to the controller 49 via a second filter 60.

Thus, in the arrangement according to Figure 5, output signals of the sensors 58, 59 are weighted by filter coefficients of the respective filters 60, 61, and controller 49 receives a weighted sum of signals related to d_2 and d_3 . In an embodiment, the filters 60, 61 are designed to provide the feedback influence of d_2 with higher weight for higher
15 frequencies and the feedback influence of d_3 with higher weight for lower frequencies.

The filters 60, 61 may be combined with the controller 49 in one unit, as will be evident to persons skilled in the art.